Space Passive Components Days 2016



ESTEC's Materials and Electrical Components laboratory capabilities on testing passive components



14 October 2016 - Joaquín José Jiménez Carreira





1. Introduction to the lab

- 2. X-ray testing
- 3. CT scan
- 4. IR techniques
- 5. C-SAM
- 6. Sectioning
- 7.SEM
- 8. FIB
- 9. Other techniques



INTRODUCTION TO THE LAB



- Support to ESA projects
- Support to ESA technology programs
- Standardization and qualification activities
- Collaborative activities with the space community
- Customer focus:
 - Time critical
 - Non-routine
 - Impartial/independent approach
 - Special confidentiality constraints
- Core functions
 - 1. Failure analysis (FA)
 - 2. Constructional analysis (CA)
 - 3. Destructive physical analysis (DPA)
 - 4. Miscellaneous investigations (MI)
 - 5. Radiation testing



European Space Agency





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X-ray testing



- 1. X-ray testing
- 2. Examples of applications:
 - Broken pad in flex circuit
 - Internal features of tantalum capacitors
 - Internal structure of relays











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Computerized Tomography (CT) scan



- Currently, two CT scan X-ray instruments at the laboratory
 - Single beam instrument: 160kV x-ray tube with CT scan tray
 - Double beam instrument: 180kV (high res) / 300kV (high density samples)
- Examples of applications
- a) Features in relays / connectors





b) Cracks in multilayer capacitors









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IR (Infra Red) techniques



- Infrared camera
- Examples of applications:
- a) Failure location in chip capacitors



unbiased



biased



b) Failure location in tantalum capacitor











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C-SAM



- C-mode Scanning Acoustic Microscopy
- Examples of applications:
 - a. Delamination in polyester capacitor







a. Delamination in tantalum capacitor











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- 1. The objective is to expose features of interest, usually failure locations
- 2. Examples of applications:
 - Expose cracks in multilayer capacitors











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7.<u>SEM</u>

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SEM (Scanning Electron Microscope)

Scanning Electron Microscope (SEM): four instruments currently at the lab

Examples of applications:

1. Exposing tin whiskers

2. Exposing internal voids

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FIB (Focused Ion Beam)

Focused Ion Beam: one **plasma FIB** and one **dual beam FIB** currently at the lab Example of applications:

1. Exposing dendrites

2. Exposing internal cracks

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Other techniques

- Vibration testing
- Mechanical shock
- PIND
- Leak testing
- RF/MW measurements
- DC electrical measurements
- Emission microscopy
- Co-60 gamma source
- Bond pull testing
- Sputter coating
- XRF
- Visual inspection

- Laser decapsulation
- Chemical decapsulation
- Metal packages decapsulation
 - Precision milling backpolisher

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ESTEC's Materials and Electrical Components Laboratory

Thank you very much for your attention!

More info about the laboratory available at www.esa.int

Technology in domain The Lab provides to Europe's space communit the facilities and expertise to investigate the Technology In domain effects of the environment on electrical components, materials and processes in support of advanced research and development, evaluation and qualification programmes and direct project support. In the materials domain support is provided on topics such as metallic materials, polymers,

> ceramics, composites as well as their associated manufacturing processes, such as curing, bonding, coatings, welding, surface

programmes

programmes

ESA Conferences

Services

mount techniques as well as cleanliness and contamination effects In the electrical components domain this encompasses all aspects of reliability analysis, failure analysis and radiation effects characterisation